

FORM PTO-1449 (Rev. 2-32) U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Atty. Docket No. 100077	Serial No. IBD 10/689,167
	Applicant: Heinz Busta	
	Filing Date: October 20, 2003	Group: IBD 2822

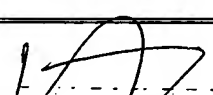
U. S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
MP	5,602,671	2/11/97	Hornbeck	_____	_____	_____
MP	5,694,740	12/9/97	Martin et al.	_____	_____	_____
MP	6,004,830	12/21/99	Potter	_____	_____	_____
MP	6,025,767	2/15/00	Kellam et al.	_____	_____	_____
MP	6,100,477	8/8/00	Randall et al.	_____	_____	_____
MP	6,109,105	8/29/00	Kubena et al.	_____	_____	_____
MP	6,198,438	3/6/01	Herd et al.	_____	_____	_____

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number								Date	Country	Class	Sub classes	Translation	
													Yes	No

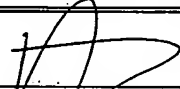
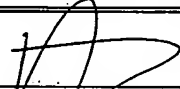
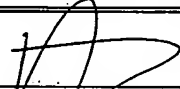
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

EXAMINER 	DATE CONSIDERED 3/05
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MP	de Boer, M.P. et al., "Tribology of MEMS," MRS Bulletin 26, April 2001, pp. 302-304.		
MP	Maboudian, R., "Surface processes in MEMS technology," Surface Science Reports 30, (1998), pp. 207-269.		
MP	Zhu, X-Y et al., "Molecular Assemblies on Silicon Surfaces via Si-O Linkages," Langmuir 16, (No. 17 2000), pp. 6766-6772.		
MP	Major, R.C. et al., "Two-Step Approach to the Formation of Organic Monolayers on the Silicon Oxide Surface," Langmuir 17, (No. 18 2001), pp.5576-5580.		
MP	Bozler, C. et al., "MEMs Microswitch Arrays for Reconfigurable Microwave Components," IEEE Antennas and Propagation Society International Symposium. Transmitting Waves of Progress to the Next Millennium, Vol. 2, 2000, pp. 587-591.		
MP	Schaffner, J.H. et al., "Reconfigurable Aperture Antennas Using RF MEMS Switches for Multi-Octave Tunability and Beam Steering," IEEE Antennas and Propagation Society International Symposium. Transmitting Waves of Progress to the Next Millennium, Vol. 1, 2000, pp. 321-324.		
MP	Chiao et al., "MEMS Millimeterwave Components," IEEE MTT-S International Microwave Symposium Digest, Vol. 2, 1999, pp. 463-466.		
MP	Brown, E.R., "RF-MEMS Switches for Reconfigurable Integrated Circuits," IEEE Transactions on Microwave Theory and Techniques, Vol. 46, No. 11, Nov. 1998, pp. 1868-1880.		
MP	Lin et al., "Rib-reinforced micromachined beam and its applications," J. Micromech. Microeng. 10, (2000), pp. 93-99.		
MP	Wilkerson et al., "Flip-Chip Hermetic Packaging of RF MEMS," MEMS Conference, 2001.		
<table border="1" style="width:100%"> <tr> <td data-bbox="82 1423 878 1497"> EXAMINER  </td> <td data-bbox="878 1423 1511 1497"> DATE CONSIDERED 3/05 </td> </tr> </table>		EXAMINER 	DATE CONSIDERED 3/05
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